

JPW #

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

TO:

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

FROM:

Tung & Associates

838 West Long Lake Road - Suite 120

Bloomfield Hills, MI 48302

DATE:

29 April 2004

REF:

Appellant

: Yang et al

Filing Date

: 1 August 2003

Serial No.

: 10/632,379

Att'y No.

: 67,200-377; TSMC 00-723

Art Unit

: 2814

Examiner

: Dana Farahani

Title

: Field Effect Transistor Device Having Corrugated Structure and

Method for Fabrication Thereof

AMENDMENT AND RESPONSE TO OFFICE ACTION

Sir:

In response to an office action mailed on 27 March 2004, please consider the following amendments and remarks pertaining to the above referenced application.

There are no amendments to the specification. Amendments to the claims are found within a Listing of the Claims that begins on page 2 of this paper. There are no amendments to the drawings. Remarks begin on page 6 of this paper.

CERTIFICATE OF MAILING

07/02/2004 BABRAHA1 00000012 10632379

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